

<b>Notice of References Cited</b>	Application/Control No. 10/756,932	Applicant(s)/Patent Under Reexamination FOCAZIO ET AL.	
	Examiner Shew-Fen Lin	Art Unit 2166	Page 1 of 1

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*	C	US-2005/0216498 A1	09-2005	Georgalas et al.	707/102
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	K	US-			
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**NON-PATENT DOCUMENTS**

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